

Transaction Information

Tool ID	NITDE-02
Tool Status	Connected
Location	Singapore
Wafer Size	200 mm
Fab Section	Diffusion
Tool Available Date	2024-10-06

General Product Information

Vendor Supplier	TOKYO ELECTRON LIMITED
Model	ALPHA-808SC
Vintage	1995
Serial No	A00009520015
Asset Description	NITDE-02
Software Version	7.03 Rev1
CIM	SECS
Process	NITDE Deposition

Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Handler System	Wafer transfer Robot	1	OK
Options System			
Others			
Main System	Main Body	1	OK
Factory Interface	SMIF	1	OK

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
None		

Missing/Faulty Parts / Accesories List

Description	Quantity
Quartzware/SIC is NOT included	









Additional Tool Data Files